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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Charles W. Pearce

Serial No.:

09/755,828

Filed:

January 4, 2001

For:

A LATERALLY DIFFUSED METAL OXIDE SEMICONDUCTOR

DEVICE AND METHOD OF MANUFACTURE THEREFOR

Group No.:

2813

Examiner:

Jack S J Chen

Commissioner for Patents Washington, D. C. 20231

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Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 2021, on 1021.

(Printed or typed name of person signing the certific

(Data of Signature)

INFORMATION DISCLOSURE STATEMENT

Pursuant to the duty of disclosure under 37 C.F.R. § 1.56, Applicant submits this statement. This submittal is made in accordance with 37 C.F.R. §§ 1.97 and 1.98 and § 609 of the Manual of Patent Examining Procedure. The patents, publications and other information herein are listed below and on the attached Form PTO-1449. Copies of the listed references are submitted herewith.

U.S. Patent No.

Inventor

Date

6,225,154

Akaishi et al.

July 3, 2001

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Applicant hereby expressly reserves the right to swear behind the effective dates of any of the above Patents and to question the relevance and materiality of the Patents and Publications listed herein, in whole, in part, or in combination, subsequent to filing this Information Disclosure Statement.

A check in the amount of \$ 180.00 is enclosed in payment of the filing fee for this communication. However, the Commissioner is hereby authorized to charge any additional fees connected with this communication or credit any overpayment to Deposit Account No. 08-2395.

Respectfully submitted,

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